



Attorney Docket No. 0492611-0543/MIT-9277CON1

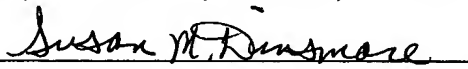
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Seleznev, et al. Examiner: Cooke
Serial No.: 10/799,436 Art Unit: 1751
Filing Date: March 12, 2004
Title: VACUUM PROCESSING FOR FABRICATION OF
SUPERCONDUCTING THIN FILMS FABRICATED BY METAL-
ORGANIC PROCESSING

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450
Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on September 22, 2005.


Susan M. Dinsmore

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

A three (3) month extension of time, from June 29, 2005 to and including September 29, 2005 is requested to file a Response to an Office Action mailed March 29, 2005, in the above-referenced application. The large entity extension fee of \$1,020.00 is enclosed herewith.

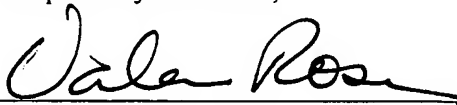
Please charge any fees associated with this filing, or apply any credits, to our Deposit Account No. 03-1721.

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1020.00 OP

Respectfully submitted,


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Dated: September 22, 2005